



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEREOLITHOGRAPHIC
METHODS FOR FORMING A
PROTECTIVE LAYER ON A
SEMICONDUCTOR DEVICE SUBSTRATE
AND SUBSTRATES INCLUDING
PROTECTIVE LAYERS SO FORMED

Confirmation No.: 1415

Examiner: G. Lee

Group Art Unit: 2825

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AMENDMENT ACCOMPANYING AN RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This Amendment accompanies the Request for Continued Examination filed even date herewith.

Amendments to the specification begin on page 3 of this paper.

Amendments to the claims are reflected in the listing of claims, which begins on page 10 of this paper.

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Corrections to the drawings are explained on page 19 of this paper; replacement sheets and an annotated sheets showing changes are attached following page 20 of this paper.

Remarks begin on page 20 of this paper.